

03500.015442.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAKAMASA ISHII ET AL.

Application No.: 09/879,214

Filed: June 13, 2001

For: SEMICONDUCTOR DEVICE,  
RADIATION DETECTION  
DEVICE, AND RADIATION  
DETECTION SYSTEM

Examiner: N.Y.A.

Group Art Unit: 2811

February 21, 2002

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APR 18 2002

Commissioner for Patents  
Washington, D.C. 20231

Technology Center 2600

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the following U.S. applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
08/964,797	11/05/1997	2823
09/845,284	05/01/2001	2814

A copy of each cited application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

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